

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/689,610	THEILER, DAVID	
	Examiner	Art Unit	Page 1 of 1
	C. Michelle Colon	3623	

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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